Notice of Allowability	Application No.	Applicant(s)	•
	09/916,444	YONEZAWA ET AL	
	Examiner	Art Unit	
	Jorge L Ortiz-Criado	2655	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS I herewith (or previously mailed), a Notice of Allowance (PTOL-8 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT of the Office or upon petition by the applicant. See 37 CFR 1.3	S (OR REMAINS) CLOSED in 5) or other appropriate commu RIGHTS. This application is s	this application. If not include nication will be mailed in due	led course, THIS
1. \boxtimes This communication is responsive to $\underline{07/06/2004}$.			
2. X The allowed claim(s) is/are 1 and 7, renumbered as 1-2 is	respectively.		
3. The drawings filed on 30 July 2001 are accepted by the l	Examiner.		•
 4. Acknowledgment is made of a claim for foreign priority a) All b) Some* c) None of the: 1. Certified copies of the priority documents ha 2. Certified copies of the priority documents ha 3. Copies of the certified copies of the priority of International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	ve been received. ve been received in Application	n No	ation from the
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the re	equirements
5. A SUBSTITUTE OATH OR DECLARATION must be sub INFORMAL PATENT APPLICATION (PTO-152) which g			NOTICE OF
 CORRECTED DRAWINGS (as "replacement sheets") m (a) including changes required by the Notice of Draftsper 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examine Paper No./Mail Date 	erson's Patent Drawing Review —·		
Identifying indicia such as the application number (see 37 CFF each sheet. Replacement sheet(s) should be labeled as such in	R 1.84(c)) should be written on th n the header according to 37 CF	e drawings in the front (not th	e back) of
7. DEPOSIT OF and/or INFORMATION about the department attached Examiner's comment regarding REQUIREMEN	posit of BIOLOGICAL MATE T FOR THE DEPOSIT OF BIO	ERIAL must be submitted. DLOGICAL MATERIAL.	Note the
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SE)	6. 🗌 Interview Su Paper No./	formal Patent Application (PT ummary (PTO-413), Mail Date Amendment/Comment	⁻ O-152)
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposi of Biological Material	t 8. ⊠ Examiner's 9. ☐ Other	Statement of Reasons for All	owance

Art Unit: 2655

DETAILED ACTION

EXAMINER'S AMENDMENT

- 1. The application has been amended as follows:
 - a. In the claims:
 - i. Clams 2-6 have been cancelled.
 - b. In the Abstract of the Specification:
 - ii. The Abstract has been replaced by:

-- An optical disk apparatus has a first optical system having an objective lens with a first NA, a second optical system having an objective lens with a second NA lower than the first NA. The optical disk apparatus at the time of processing the optical disk, when the optical system suitable recording/reproduction process of the optical disk is the second optical system, via the first optical system detecting a surface run-out of the optical disk and execute the focus lead-in process of the second optical system on the basis of a surface run-out detected; and when at the time of processing the optical disk, when the optical system suitable recording/reproduction process of the optical disk is the first optical system, processing the optical disk with the first optical system without detecting the surface run-out of the optical disk.--

Art Unit: 2655

Election/Restrictions

2. This application is in condition for allowance except for the presence of claims 2-6 to a Species non-elected without traverse. Accordingly, claims 2-6 have been cancelled.

Allowable Subject Matter

3. Claims 1 and 7 are allowed.

The following is an examiner's statement of reasons for allowance:

The prior art teaches an optical disk process means for executing a focus lead-in process by irradiating a rotating predetermined optical disk with a light beam applied via a first objective lens of a first optical system, said first objective lens having a first numerical aperture lower than a second numerical aperture of a second objective lens of a second optical system; discriminating an optical system suitable for a recording/reproduction process of the optical disk; processing the optical disk, when the optical system suitable for the recording/reproduction process of the optical disk is the first optical system, by irradiating the optical disk with the light beam via the first objective lens of the first optical system; processing the optical disk, when the optical system suitable for the recording/reproduction process of the optical disk is the second optical system, by irradiating the optical disk with the light beam via the second objective lens of the second optical system.

Applicant's claimed invention is deemed allowable over the prior art of record as the prior art fails to teach or suggest either alone or in combination when at the time of processing

Art Unit: 2655

the optical disk, when the optical system suitable recording/reproduction process of the optical disk is the second optical system, irradiating the optical disk with the light beam via the first objective lens of the first optical system and detecting surface run-out of the optical disk to execute the focus lead-in process by irradiating the optical disk with the light beam via the second optical system on the basis of a surface run-out detected; and specifically when at the time of processing the optical disk, when the optical system suitable recording/reproduction process of the optical disk is the first optical system, processing the optical disk with the first optical system without detecting the surface run-out of the optical disk.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jorge L Ortiz-Criado whose telephone number is (703) 305-8323. The examiner can normally be reached on Mon.-Thu.(8:30 am - 6:00 pm), Alternate Fridays off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Doris H To can be reached on (703) 305-4827. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Art Unit: 2655

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

joc

W/R. YOUNG RIMARY EXAMINER